

Electronic Acknowledgement Receipt

EFS ID:	1974151
Application Number:	10593857
International Application Number:	
Confirmation Number:	5813
Title of Invention:	Plasma Chamber Having Plasma Source Coil and Method for Etching the Wafer Using the Same
First Named Inventor/Applicant Name:	Nam Hun Kim
Customer Number:	23363
Filer:	D. Bruce Prout/Vickie Wall
Filer Authorized By:	D. Bruce Prout
Attorney Docket Number:	58409/N305
Receipt Date:	16-JUL-2007
Filing Date:	22-SEP-2006
Time Stamp:	21:34:47
Application Type:	U.S. National Stage under 35 USC 371

Payment information:

Submitted with Payment	no
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File Listing:

Document Number	Document Description	File Name	File Size(Bytes) /Message Digest	Multi Part /.zip	Pages (if appl.)
1	Request for Corrected Filing Receipt	58409_Letter_to_Correct_Filing_Receipt.pdf	36740 <small>e0354662d087ed931e2518b33ce358137e73991</small>	no	2

Warnings:

Information:					
2	Request for Corrected Filing Receipt	58409_Filing_Receipt.pdf	138200	no	3
			5a712c1e025ac7b2cd99a40ce13018734b311dd8		

Warnings:

Information:

3	Request for Corrected Filing Receipt	58409_Declaration.pdf	83904	no	2
			62f5a000d8c0a45d1f8dd9f7949b9771060359		

Warnings:

Information:

Total Files Size (in bytes):		258844
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New Applications Under 35 U.S.C. 111

If a new application is being filed and the application includes the necessary components for a filing date (see 37 CFR 1.53(b)-(d) and MPEP 506), a Filing Receipt (37 CFR 1.54) will be issued in due course and the date shown on this Acknowledgement Receipt will establish the filing date of the application.

National Stage of an International Application under 35 U.S.C. 371

If a timely submission to enter the national stage of an international application is compliant with the conditions of 35 U.S.C. 371 and other applicable requirements a Form PCT/DO/EO/903 indicating acceptance of the application as a national stage submission under 35 U.S.C. 371 will be issued in addition to the Filing Receipt, in due course.

New International Application Filed with the USPTO as a Receiving Office

If a new international application is being filed and the international application includes the necessary components for an international filing date (see PCT Article 11 and MPEP 1810), a Notification of the International Application Number and of the International Filing Date (Form PCT/RO/105) will be issued in due course, subject to prescriptions concerning national security, and the date shown on this Acknowledgement Receipt will establish the international filing date of the application.